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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet 1

of 2_

Application Number $\frac{4bd}{10/622,247}$ Filing Date First Named Inventor Lim Art Unit 2857 Examiner Name PHUONG HUYNH Attorney Docket Number CS01-150

				DOCUMENTS	1 0 O.L 1' 140
Examiner Initials	No.1	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
PH		US 6,403,389B1	0411/2002	Chang et al	
		US 5,627,101	5/6/1997	Lin et al.	
		US- 5,987,398		Halverson et al.	
		US- 5,883,437 B		Maruyama et al.	
		US-6,466,038	10/15/2000	Pekin	
		US- 5,514,974	5/7/2996	Bouldin	
V		US- 6,087,189 ~	7/11/2000	Huang	
PH		US- 5,552,718	5/3/1996	Bruce	
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		FOREI	GN PATENT DOCU	MENTS		
Examiner Initials*	Cite No.1	Foreign Patent Document	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages	Γ.
		Country Code ³ Number ⁴ Kind Code ⁵ (# known)	MM-DD-YYYY		Or Relevant Figures Appear	Τ٥
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Examiner 07/06/2006 Considered Phuong Huynh/

PRUONG HUYNA!

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered, include copy of this form with next communication to applicant. Applicant's unique citation designation number (optional). See Kinds Codes of USPTO Patient Documents at www.uspto.gov or WPEP 901.04. Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). For USPTO Patient Documents, the indication of the year of the region of the Emperor must precede the serial number of the petent document. Nind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. Applicant is to place a check mark here if English language Translation is attached.

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Substitute for form 1449/PTO	Complete if Known			
	Application Number	Tan 10/622,247		
INFORMATION DISCLOSURE	Filing Date			
STATEMENT BY APPLICANT	First Named Inventor	Lim ·		
	Art Unit	2857		
(Lise as many sheets as necessary)	Examiner Name	PHUONG HUYI	NH	
Sheet 2 of 2	Attorney Docket Number	cs01-50		

		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
РН		PLUSQUELLIC et al., "Identification of defective CMOS devices using Correlation and Regression Analysis Date" was it www.csee.umBC.edu	

Examiner	/m1 1 /	Date	
Signature	/Phuong Huynh/	Considered	07/06/2006

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1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached. This collection of Information is required by 37 CFR 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 120 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, Washington, DC 20231.



S/N TBD

Docket: CS01-150

Group art unit: ____TBD

The following Patents and/or Publication are submitted to comply with the duty to disclose under CFR 1.97-1.99 and 37 CFR 1.56. Copies of each document is included herewith.

US 6,403,389B1 (Chang et al.) shows a method for measuring sheet resistance.

US 5,627,101(Lin et al.) shows a test method for a electro migration using a Metal and Poly test structure.

US 5,987,398(Halverson et al.) shows a method for SPC for a process having a non-constant mean of a response variable.

US 5,883,437 (Maruyama et al.) discloses a method for applying a time varying voltage between the electrode and wiring pattern at different locations so as to detect a current flow and determine a defect by a variation in the detected current flow at the different locations and a portion of the defect.

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Docket: CS01-150

Group art unit : TBD

isothermal electro migration testing of interconnects.

US 5,514,974 (Bouldin) shows a method for testing for metal failures by using 2 different test structures.

US 6,087,189 (Huang) shows test structure to monitor silicide.

US 5,552,718 (Bruce et al.) shows a test structure for space and line measurement.

Plusquellic et al., "Identification of defective CMOS devices using Correlation and Regression Analysis of Frequency Domain Transient Signal data", retrieved from website http://www.csee.umbc.edu/~plusquel/pubs/itc97.pdf on about May 20, 2003. No publication date listed.

Sincerely,

William J. Stoffel Reg. No. 39,390 Customer number 30,402